



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 7, 2024	
IGI Report Number	LG656495864
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	9.28 X 6.77 X 4.63 MM

GRADING RESULTS

Carat Weight	2.83 CARATS
Color Grade	E
Clarity Grade	VS 1

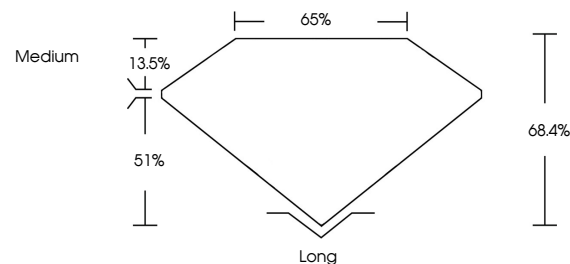
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG656495864

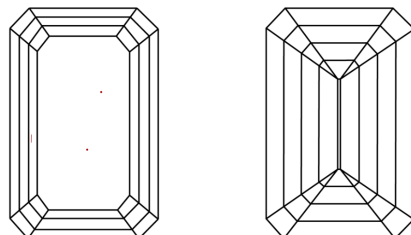
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG656495864
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

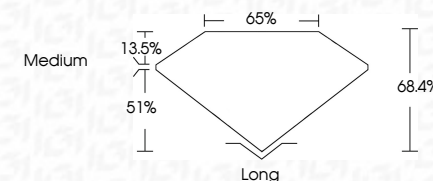
IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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October 7, 2024
GI Report No LG656495864

	2.28 X 6.77 X 4.63 MM		
	Carat Weight	2.88 CARATS	
	Color Grade	E	
	Clarity Grade	VS 1	
	Depth	68.4%	
	Table	65%	
	Grade	Medium	
	Culet	Long	
	Polish	EXCELLENT	
	Symmetry	EXCELLENT	
	Fluorescence	NONE	

Comments:
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(CVD) growth process.